

**Europe Fall Standards Meeting Schedule**

**Dresden, Germany**

**This schedule is subject to change without notice.**

7:00	8:00	9:00	10:00	11:00	12:00	13:00	14:00	15:00	16:00	17:00	18:00	19:00	20:00
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**Monday, October 18, 2010**

<b>MEETING LOCATIONS</b>		<b>Messe Dresden</b> Messering 6, D-01067 Dresden, Germany		<b>SolarWatt Facilities</b> Dresden, Germany	
<b>Photovoltaic Automation</b> <i>(Room:SolarWatt A)</i>		<b>PV EIS (TF)</b> 09:00-11:00	<b>PV Transport Carrier (TF)</b> 11:00-13:00	<b>PV Automation (C)</b> 13:00-16:30	<b>Solarwatt Facilities tour</b> (17:00-18:00)

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**Tuesday, October 19, 2010**

<b>Equipment Automation</b> <i>(Room:SolarWatt B)</i>			<b>Integrated Measurement (TF)</b> 12:00-14:00	<b>Equipment Automation (C)</b> 14:00-17:00	
<b>Photovoltaic</b> <i>(Room:SolarWatt B)</i>		<b>PV Connector Ribbon (TF)</b> 08:00-10:00	<b>PV Gas and Liquid Chemicals Purity (TF)</b> 10:00-12:00		
<b>Photovoltaic</b> <i>(Room:SolarWatt A)</i>		<b>PV Silicon Materials (TF)</b> 09:00-11:00	<b>PV Minority Carrier Lifetime (WG)</b> 11:00-12:00	<b>PV Analytical Test Methods (TF)</b> 12:00-14:00	<b>Photovoltaic (C)</b> 14:00-17:00

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**Wednesday, October 20, 2010**

<b>Gases and Chemicals</b> <i>(Hall 4, Room 4.3 Breslau)</i>			<b>Gases &amp; Liquid Chemicals (TF)</b> 10:00-12:30		<b>Gases &amp; Liquid Chemicals (C)</b> 14:00-17:00
<b>Photovoltaic</b> <i>(Room Erlwein)</i>			<b>PV Wafer Mark and ID (TF)</b> 08:00-11:45		
<b>Silicon Wafer</b> <i>(Hall 4, Room 4.2 Strassburg)</i>		<b>Int' 450 mm Wafer (TF)</b> 08:00-10:00	<b>Int' Advanced Wafer Geometry (TF)</b> 10:00-12:00	<b>(By Invitation Only) Silicon Wafer GCS</b> 12:30-13:30	<b>Silicon Wafer (C)</b> 14:00-17:00
<b>ERSC</b> <i>(Hall 4, Room 4.1 Ostrava)</i>					<b>Recent Update on Procedure Guide &amp; Regs Mtg</b> 17:00-17:30
					<b>(By Invitation Only) ERSC</b> 17:30-20:00

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**Thursday, October 21, 2010**

<b>Compound Semiconductors</b> <i>(Hall 4, Room 4.3 Breslau)</i>		<b>Compound Semiconductor (TF)</b> 08:30-12:15		<b>Compound Semiconductor (C)</b> 13:00-15:00	
<b>Environmental Health &amp; Safety</b> <i>(Hall 4, Room 4.2 Strassburg)</i>		<b>Environmental Health &amp; Safety (C)</b> 09:00-12:00			